



U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MICRON.098DV1	APPLICATION NO. 09/971,955
INFORMATION DISCLOSURE STATEMENT BY APPLICANT			
(USE SEVERAL SHEETS IF NECESSARY)			
APPLICANT Basceri et al.			
FILING DATE October 4, 2001		GROUP 2811	

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPROPRIATE)
an	5,185,689	02/09/93	Maniar			
ca	5,406,445	04/11/95	Fujii et al.			
ca	5,581,436	12/03/96	Summerfelt et al.			
ca	5,781,404	07/14/98	Summerfelt et al.			
ca	5,822,175	10/13/98	Azuma			
ca	6,238,966	05/29/01	Ueda et al.			
ca	6,277,436	08/21/01	Stauf et al.			
ca	6,319,764	11/20/01	Basceri et al.			
ca	6,339,527	01/15/02	Farooq et al.			

FOREIGN PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
						YES NO

EXAMINER INITIAL	OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)	

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EXAMINER	<i>Daggy</i>	DATE CONSIDERED	<i>7-18-04</i>
*EXAMINER: INITIAL IF CITATION CONSIDERED. WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP 609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED. INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.			

<p style="text-align: center;">U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE</p> <p style="text-align: center;">INFORMATION DISCLOSURE STATEMENT BY APPLICANT</p> <p style="text-align: center;">(USE SEVERAL SHEETS IF NECESSARY)</p>			ATTY. DOCKET NO. MICRON.098DV1	APPLICATION NO. 08/971,955
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U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPROPRIATE)
an	1	6,285,051	09/04/01	Ueda et al.	257	298	
an	2	6,339,527	01/15/02	Farooq et al.	361	305	

FOREIGN PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
							YES NO
an	3	WO95/25340	09/21/95	PCT			

EXAMINER INITIAL	OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)	
an	4	Joo, "Fabrication and Characterization of MOCVD (Ba, Sr)TiO ₃ Thin Films for High Density Capacitors", Proceeding of 1997 5th International Conference on VLSI and CAD", The Secretariat of ICVC '97, 1997.

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EXAMINER	<i>Deg</i>	DATE CONSIDERED	<i>7-18-04</i>
*EXAMINER: INITIAL IF CITATION CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP 609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED, INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.			